

## International Journal of Scientific Research in Science and Technology

### CERTIFICATE OF PUBLICATION

Ref : IJSRST/Certificate/Volume 3/Issue 1/754

19-Jan-2017

This is to certify that **S. Abdullahi, M. Momoh, A. U. Moreh, A. M. Bayawa, B. Hamza, G. M. Argungu, O. T. Popoola** have published a research paper entitled '*Growth Mechanism and influence of annealing temperature on structural and compositional properties of  $Cu^2ZnSnS^4$  (CZTS) thin films deposited by RF sputtering method from a compound target.*' in the International Journal of Scientific Research in Science and Technology (IJSRST), Volume 3, Issue 1, January-February-2017.

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Online ISSN : 2395-602X

Print ISSN : 2395-6011

[ UGC Journal No : 64011 ]

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